

PATENT
57A 3127

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

YOSHIKAZU NAKAYAMA et al.

Serial No.: 09/915,618

Filed: July 26, 2001

For: LITHOGRAPHIC METHOD USING
ULTRA-FINE PROBE NEEDLE

Art Unit: 2853

Examiner: Alfred E. Dudding

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AMENDMENTCommissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Dear Sir:

In response to the Office Action dated September 16, 2003, please amend the above-identified application as follows: